## **EAST Search History**

| Ref<br># | Hits | Search Query  | DBs   | Default<br>Operator | Plurals | Time Stamp       |
|----------|------|---|---|---------------------|---------|------------------|
| L1       | 2021 | (438/3).CCLS.   | US-PGPUB;<br>USPAT;<br>USOCR;<br>EPO; JPO;<br>DERWENT;<br>IBM_TDB | OR                  | OFF     | 2006/06/21 09:58 |
| L2       | 1069 | L1 and ("Al.sub.2O.sub.3" or<br>Aluminum or AIO or AION or AIN)   | US-PGPUB;<br>USPAT;<br>USOCR;<br>EPO; JPO;<br>DERWENT;<br>IBM_TDB | OR                  | ON      | 2006/06/21 10:07 |
| L3       | 1069 | L1 and ("Al.sub.2O.sub.3" or<br>Aluminum or AlO or AlON or AlN or<br>(aluminum near oxide) or (aluminum<br>near nitride) or (aluminum near<br>oxynitride))  | US-PGPUB;<br>USPAT;<br>USOCR;<br>EPO; JPO;<br>DERWENT;<br>IBM_TDB | OR                  | ON      | 2006/06/21 10:29 |
| L8       | 44   | ((capacitor near4 dielectric) and ((first or bottom or lower) near (plate or electrode or node or conductive)) and ((second or top or upper) near (plate or electrode or node or conductive)) and (aluminum or "Al.sub.2O.sub.3" or (aluminum near oxide) or (aluminum near nitride) or (aluminum near oxynitride) or AlO or AlN or AlON) and capacitor and temperature and (expos\$4 or treat\$4 or oxidiz\$4 or nitridiz\$4 or react\$4) and (O or N or oxygen or nitrogen)).clm. | US-PGPUB  | OR                  | ON      | 2006/06/21 11:35 |